

The vacuum control system at CERN

André Rocha (andre.rocha@cern.ch)

Interlocks, Controls and Monitoring Section, Vacuum Group

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Technology De

Technology Department

Vacuum at CERN

Why accelerators need vacuum

Control System Architecture

How the vacuum control system is structured

Configuration Infrastructure

How we manage configuration and deploy our control system

Limitations to scalability

Is there any roadblock for a larger system?

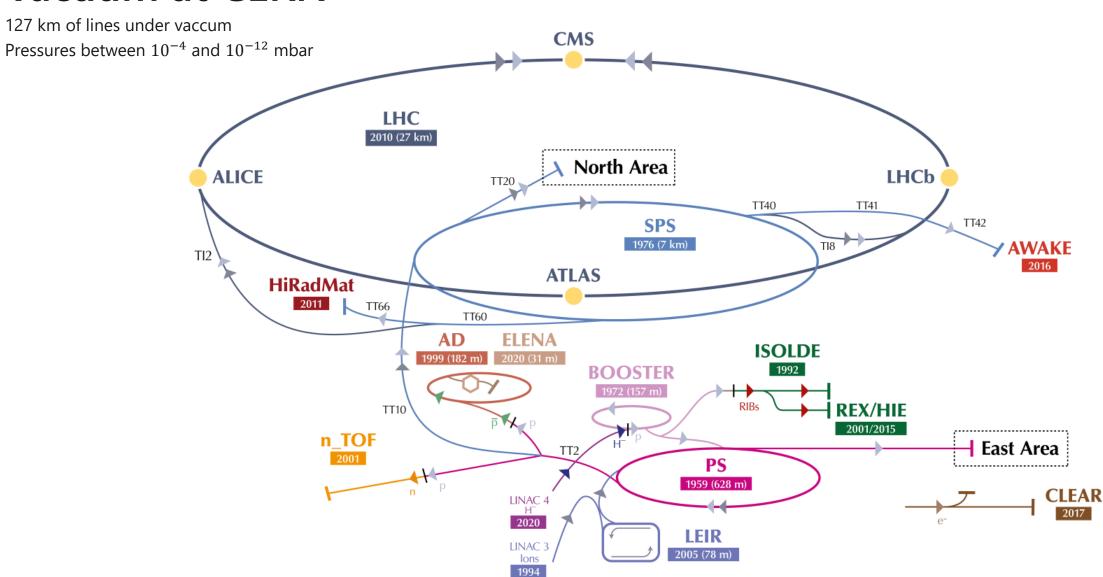
Trends and a Possible Future Architecture

What if we had to build FCC today?

Conclusions

Key takeaways

Vacuum at CERN



Pressure on LHC beam lines is between 10^{-10} and 10^{-11} mbar



10 times less than the pressure on the moon







Beam Vacuum

Objective:

Reduce the interaction between the beam and residual gas molecules

Increased Beam Lifetime

Less particles lost at each turn

Increased Beam Stability

Less interference to beam dynamics

Increased Beam Luminosity

Better focused beam

Reduced Experiment Background noise

Less scattered particles

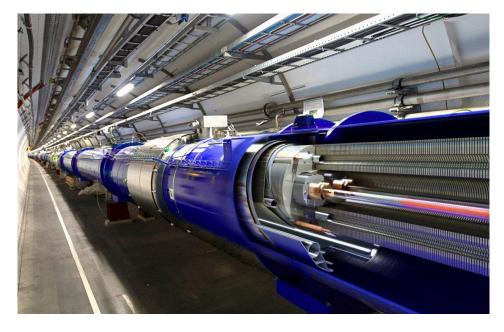
Insulation Vacuum

Objective:

Thermal insulation for magnets and helium distribution

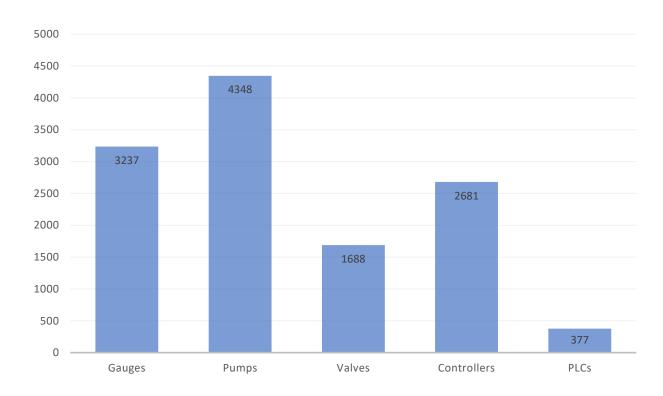
- To guide the beam, 1200 8T magnets are used
- Current of 12kA
- Superconductivity is necessary
 - 0 electrical resistivity
 - Reduced size of conductors
- Superconductivity achieved with liquid Helium
- Vacuum is used as thermal insulator for magnets and helium distribution

LHC Dipole

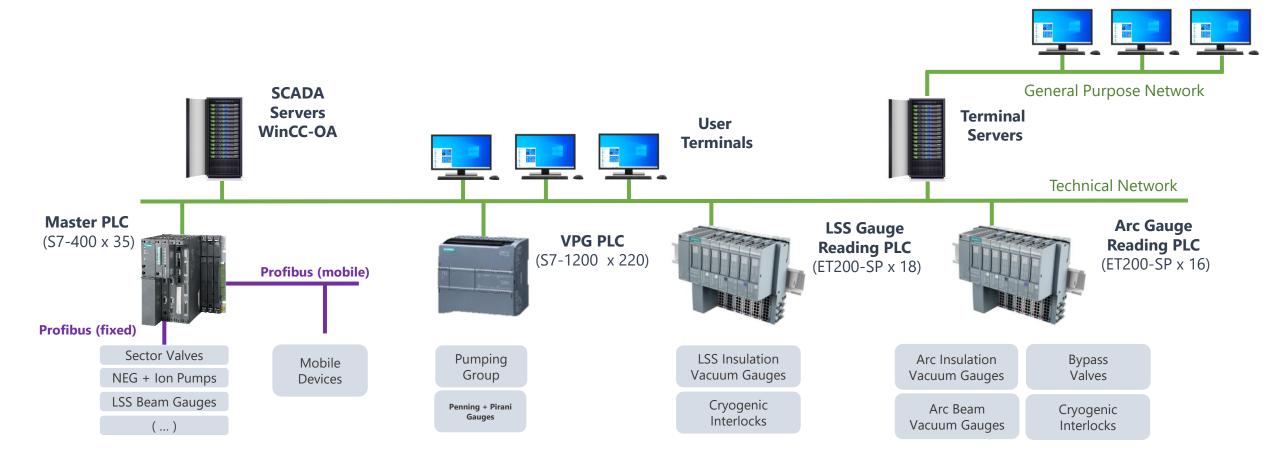


Process Equipment numbers

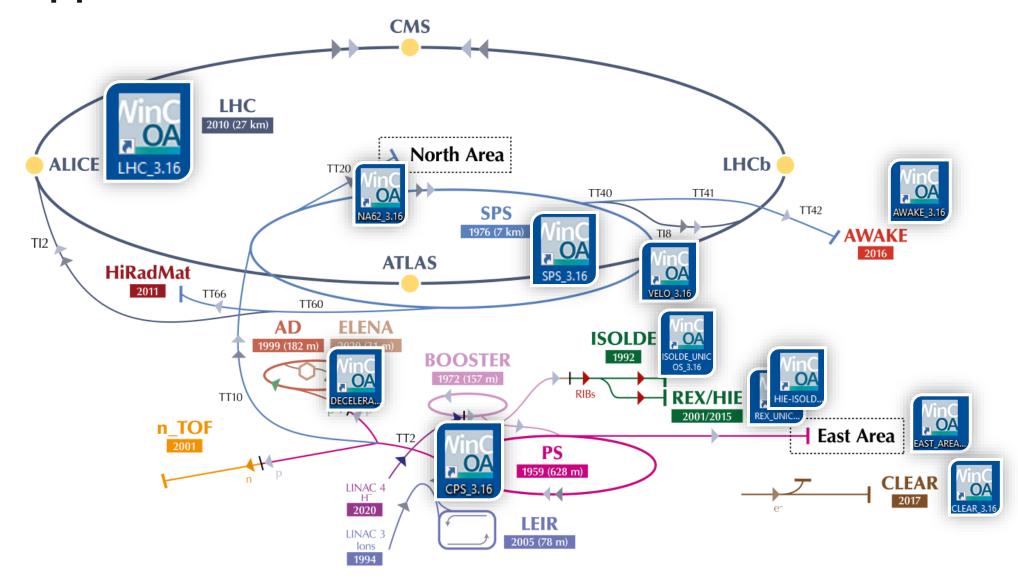
Vacuum is achieved and monitored by over 12000 pieces of control equipment



Control System Architecture



SCADA Applications as of 2023



Configuration settings numbers

LHC 617 632

SPS 147 315 **CPS** 100 783





Alarms

Alarm descriptions
Alarm hierarchies



Communication

SCADA <-> PLC <-> Device



Attributes required to control devices





vacDB



Display

The location of equipment in synoptics



Archiving

What to archive. Which archive settings? Archive duration



Data Sharing

What to share to other systems?

Vacuum Databases

Machine DBs

Master DB

Master Database

For each device type:

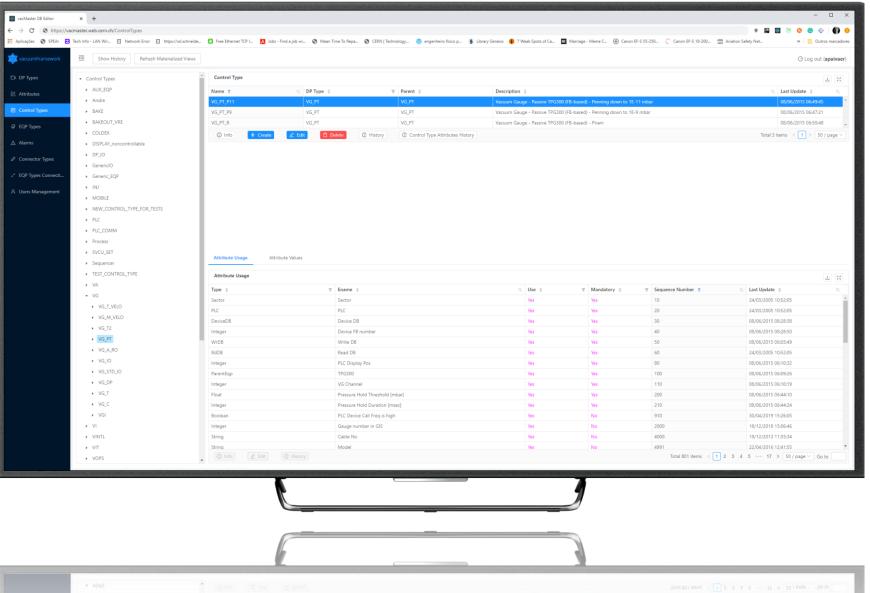
- Definition of Vacuum Equipment Types
- Definition of Attributes
- Definition of Default Attribute values
- Definition of Communication block
- Definition of SCADA datapoint type
- Definition of alarms produced

Machine Databases

Instantiation of equipment
Specification of equipment attributes
Specification of archiving settings
Specification of data sharing

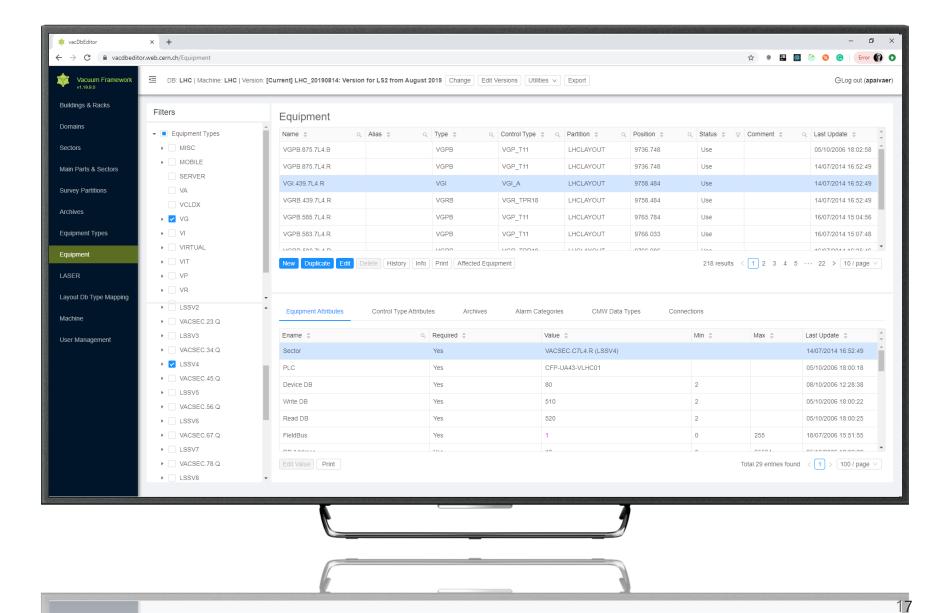
vacCC Master

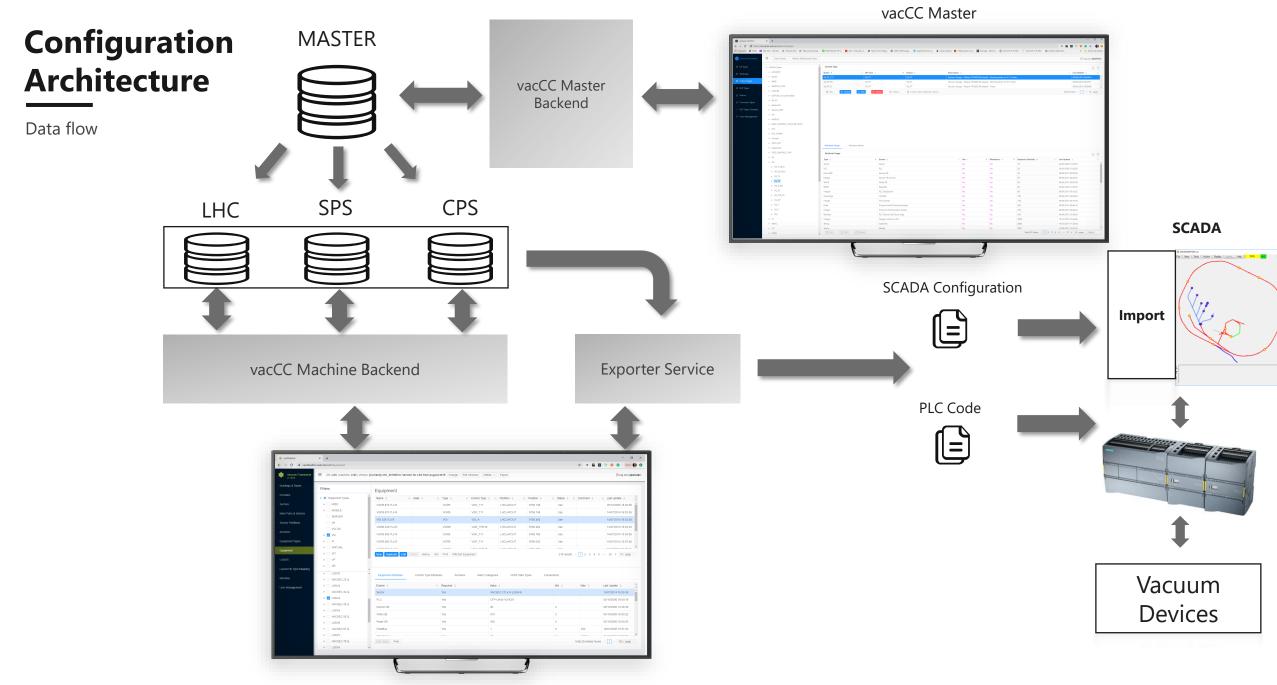
The metadata editor
Used by SCADA developers
Definition of defaults for each eqp type



vacCC Machine

- The editor for the machine databases
- Allows integration of equipment in the control system by non software experts
- Full traceability





vacCC Machine

Advantages of Database-Driven Configuration Engineering Tools

Cross-layer consistency

• Changes of parameters are propagated to all relevant layers of the control system

Data integrity

• Configuration integrity and consistency done by defining rules for data validation and constraints

Assessibility

• Multiple people can work in the configuration of the control system at the same time

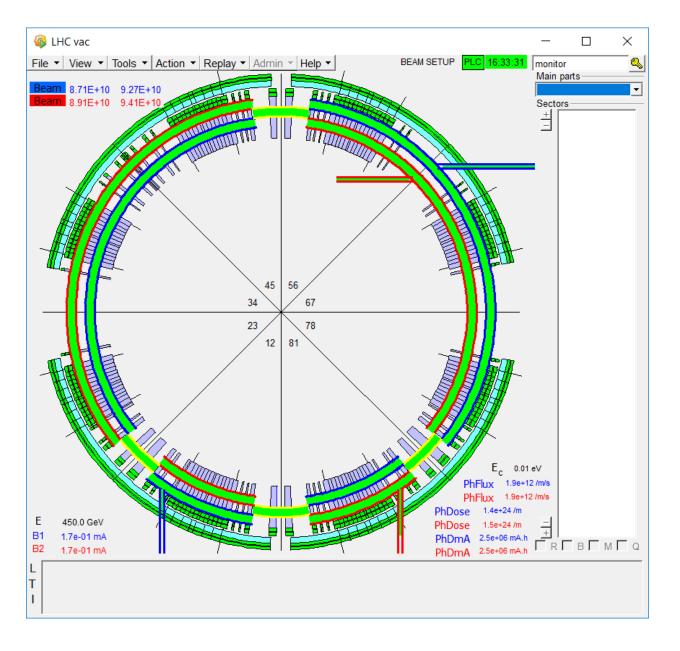
Versioning

• Have different versions of the control system ready in advance according to the needs of operations

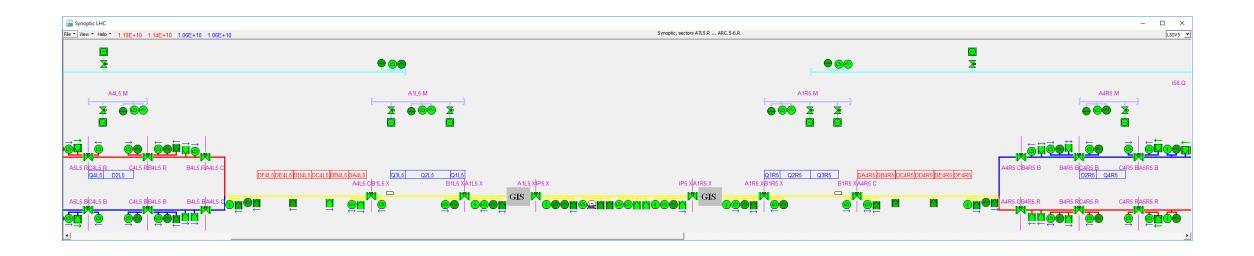
History

• Log every change. Know what changed, when it changed and who changed what.

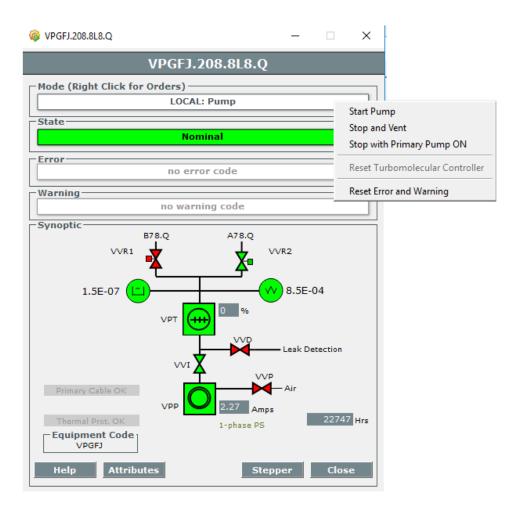
SCADA User Interface



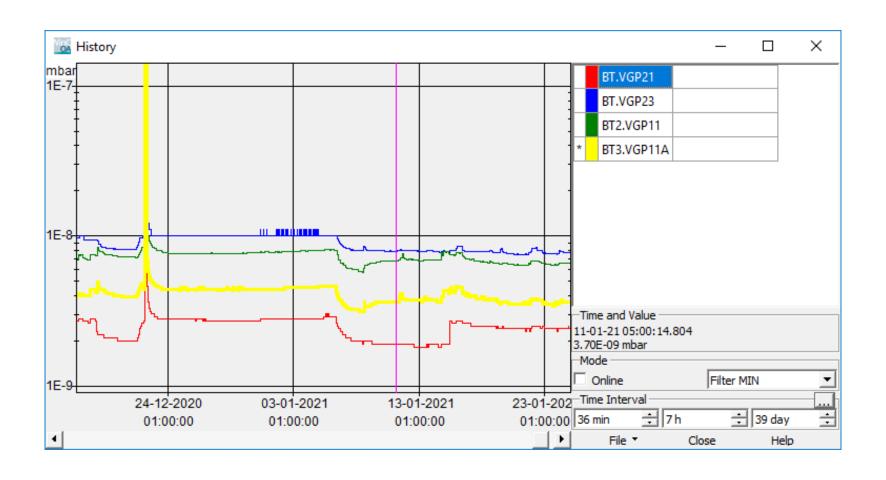
Automatic Synoptic Drawing



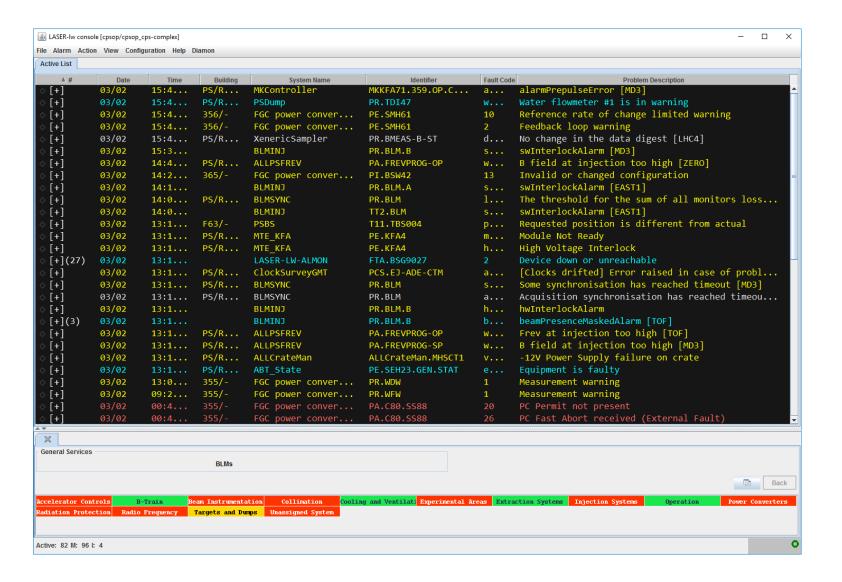
Equipment Details Panel



Archiving



Alarms



WinCC-OA Limitations to Scalability

(known) factors that may eventually limit our current architecture

Source: https://www.winccoa.com/documentation/WinCCOA/3.18/en_US/Installation/Operating_Conditions.html



Devices and datapoint elements

Maximum number of datapoint elements: ~16M Implications on memory and CPU load LHC: currently at 400.000



Memory and CPU

Average CPU load by event manager should be < 20%

Summarized average CPU of all WinCC-OA processes (drivers, event, data, ctrl) should be < 50 %

LHC Total CPU load < 3% / Event Manager Load 10% on single core

LHC currently at 14GB/256GB memory usage



Number of PLC Connections

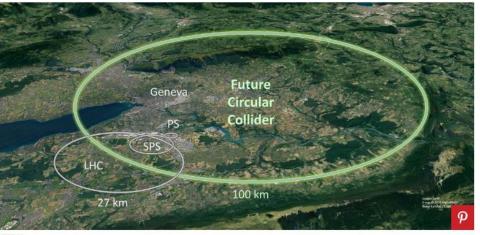
Maximum number of 512 connections per system LHC currently with 300 connections

Scientists Are Planning a New Particle Collider That Absolutely Dwarfs the LHC

The proposed Future Circular Collider will be around ten times as powerful as the Large Hadron Collider.



☐ SAVE ARTICLE



CERN

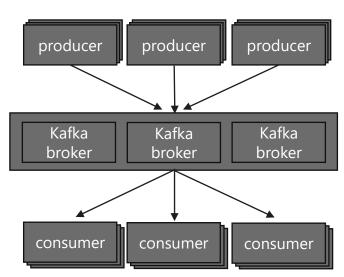
Scaling to FCC

- Scaling our current architecture to an accelerator the size of FCC won't work
 - FCC planned size is roughly 4 times that of LHC
 - WinCC-OA is limited to 512 PLC connections
 - LHC has 300 PLCs x 4 = 1 200 PLCs too many connections
- (New) trends have to be considered for future control system architectures
 - Integration of IOT devices
 - Advanced real time data analytics increasingly important on large scale systems with huge amounts of data to analyze
 - Data pipelines provide robust ways of moving large amounts of data between the different parts of the control system

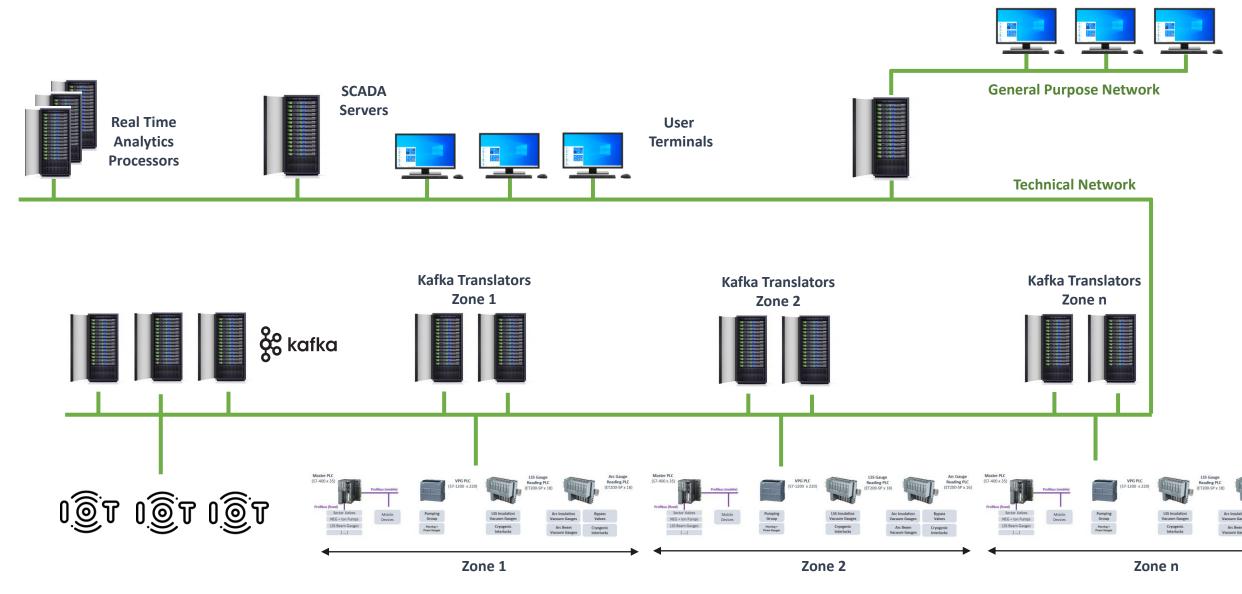
Kafka

- Distributed streaming platform
- Publish/subscribe messaging system based on topics
- High Throughput / Low latency
 - Hundreds of thousands of messages per second on a single broker
- Scalable without compromising performance
 - Designed to scale horizontally by adding more brokers to the cluster
 - Topic partitioning distribute data across multiple brokers
- Highly available and Fault-tolerant
 - Automatic Failover
 - Topic replication
- Ecosystem of pre-made connectors, allowing to integrate kafka with a multitude of systems
 - https://docs.confluent.io/kafka-connectors/self-managed/kafka_connectors.html#kafka-connectors





Control System Architecture



Conclusion

• Database-driven Configuration Engineering tools are essential to manage large-scale control systems:

- · Provide a centralized location for storing and managing equipment configurations, making it easier to maintain and update control systems
- Allow for more efficient collaboration between multiple teams working on different aspects of a control system
- Improve the reliability and safety of control systems by ensuring that equipment configurations are consistent and correctly applied in the relevant layers
- Allows operators to track and monitor changes made to control system parameters, providing a clear audit trail of modifications

Distributed streaming technologies can help us evolve our control system architecture:

- Provide greater scalability, enabling control systems to handle larger and more complex deployments
- Enable real-time analytics, allowing for more proactive and predictive maintenance strategies
- Open up new possibilities for integrating different types of equipment and technologies, improving interoperability and reducing vendor lock-in

Thank you!